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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Scott Goad et al.

§ Group No.:

Serial No.: 10/693,016

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Examiner:

Filed: October 24, 2003

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For: ASYMMETRIC HALO IMPLANTS

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Atty. Dkt. No.: AMDI:131\HON

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

CERTIFICATE OF MAILING 37 C.F.R. 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on the date below:

Date

January 17, 2004 Timothy M. Honeycutt

Dear Sir:

**INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. 1.97(b)(1) AND 1.98**

In compliance with the duty of disclosure under 37 C.F.R. 1.56(a), Applicants respectfully request that this Information Disclosure Statement be entered and that the reference(s) listed in the form PTO-1449 filed concurrently herewith be considered by the Examiner and made of record. Copies of any non-U.S. patent references listed in the accompanying form PTO-1449 are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R. 1.97, this Information Disclosure Statement is not to be construed as a representation that a search has been made, as an admission that the information cited in the accompanying form PTO-1449 is, or is considered to be, material to patentability as defined in 37 C.F.R. 1.56(b), or as a representation that no other possibly material information, as defined in 37 C.F.R. 1.56(b), exists.

The information is listed in the accompanying form PTO-1449 in accordance with 37 C.F.R. 1.98. Any explanation of non-English language documents cited in the accompanying form PTO-1449 is believed to constitute a concise explanation of the relevance of the listed reference(s) as they are presently understood by the individual designated in 37 C.F.R. 1.56(c) most knowledgeable about the content of the listed reference(s), in accordance with 37 C.F.R. 1.98(a)(3).

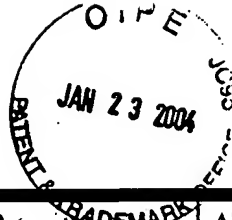
The Commissioner is authorized to charge any required fees or credit any overpayment to
Deposit Account No. 01-0365, Order No. AMDI:131\HON.

Respectfully submitted,

Date: January 17, 2004



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Form PTO-1449 (modified) List of Patents and Publications For Applicant's Information Disclosure Statement (Use several sheets if necessary)		ATTY. DOCKET NO. AMDI:131\HON		SERIAL NO. 10/693,016			
		APPLICANT Scott Goad et al.		CERTIFICATE OF MAILING 37 C.F.R. 1.8 I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on the date below: January 17, 2004 Date Timothy M. Honeycutt			
		FILING DATE October 24, 2003		GROUP			
U.S. PATENT DOCUMENTS							
EXAM INIT.	REF. DES.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	A1	6,114,211	September 5, 2000	H. Jim Fulford et al.	448	305	
	A2	5,227,321	July 13, 1993	Ruojia Lee et al.	437	44	
FOREIGN PATENT DOCUMENTS							
EXAM INIT.	REF. DES.	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION
OTHER ART							
EXAM INIT.	REF. DES.	AUTHOR; TITLE; JOURNAL; VOLUME; DATE; PERTINENT PAGES					
	A3	Stanley Wolf and Richard N. Tauber; <i>Silicon Processing for the VLSI Era, Volume 3 - The Submicron MOSFET</i> ; pp.226-232, 240, 309-311 and 621-622; 1995					
	A4	Terence B. Hook et al.; <i>High-Performance Logic and High-Gain Analog CMOS Transistors Formed by a Shadow-Mask Technique With a Single Implant Step</i> ; IEEE Transactions on Electron Devices, Vol. 49, No. 9, September 2002; pp. 1623-1627					
EXAMINER				DATE CONSIDERED			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Information Disclosure Statement--PTO-1449 (Modified)